



## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Patent Application of:

Hideto OHNUMA

Application No. 10/053,572

Filed: January 24, 2002

For: METHOD OF MANUFACTURING

COPY OF PAPERS  
ORIGINALLY FILED

SEMICONDUCTOR DEVICE

) Group Art Unit: 2812

) Examiner: Unknown

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## CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Commissioner for Patents, Washington, D.C. 20231, on March 19, 2002.

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents and Trademarks  
Washington, D.C. 20231

Sir:


In accordance with the provisions of 37 C.F.R. 1.56 and 37 C.F.R. 1.97-1.99, it is requested that the reference listed on the attached Form PTO-1449 be made of record in the above-identified application. A copy of the reference is submitted herewith in accordance with 37 C.F.R. 1.98(a).

The reference appears to disclose a UV oxidation treatment process in paragraph [0020], which is similar to an ozone water treatment of the present application.

The document is being submitted within 3 months of the filing, or entry into the national phase, of this application or before the first Office Action on the merits, whichever is later, therefore no fee or certification is required under 37 C.F.R. § 1.97(b).

The Commissioner is hereby authorized to charge fees under 37 C.F.R. §§1.16, 1.17, 1.20(a), 1.20(b), 1.20(c), and 1.20(d) (except the Issue Fee) which may be required now or hereafter, or credit any overpayment to Deposit Account No. 19-2380 (740756-2422).

Respectfully Submitted,

  
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